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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/712,775

Filing Date: November 14, 2003

Applicant: Donggyun HAN, et al.

Group Art Unit: 1792

Examiner: Anita Alanko

Title: APPARATUS AND METHOD FOR REMOVING  
PHOTORESIST FROM A SUBSTRATE

Attorney Docket: 2557-000216/US

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***LETTER***

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
**Mail Stop Issue Fee**

July 10, 2008

Dear Sir:

An Information Disclosure Statement was submitted on December 29, 2005.

Applicants have received a copy of the filing and would like to amend a typographical error in the PTO-1449. A copy of the previously filed PTO-1449 with corrections to the typographical errors marked in bold type is attached hereto.

The change is as follows:

On the PTO-1449, the number of Reference No. 8 should read "2003/0045117" instead of "2002/0045117", to "Cotte et al." instead of "Shimida et al.". A new PTO-1449 is enclosed.

The Examiner has considered this reference after a telephone conference conducted with Erin G. Hoffman on July 10, 2008. This correction is being submitted to ensure that the record is clear.

Please replace the corresponding sheet in the file. This letter is being submitted to clarify the record and no further action or fee is deemed to be necessary. However, if necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully Submitted,

HARNESS, DICKEY & PIERCE, PLC

By

  
for

John A. Castellano, Reg. No. 35,094

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JAC/EGH:ljs

Enclosure: New Form PTO-1449